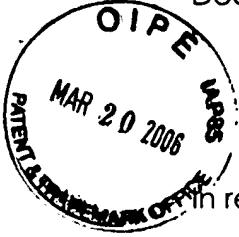


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the application of:

Mark L. Doczy, et al.

Serial No.: 10/748,545

Filed: December 29, 2003

Title: **A METHOD FOR MAKING A  
SEMICONDUCTOR DEVICE THAT  
INCLUDES A METAL GATE ELECTRODE**

Examiner: Thanh T. Nguyen

Art Unit: 2813

Confirmation No. 9131

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed November 15, 2005, Applicants respectfully request entry of the following amendments and consideration of the following remarks.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

On: 3/15/2006

Signature

Julie Dussault

3/15/2006

Date